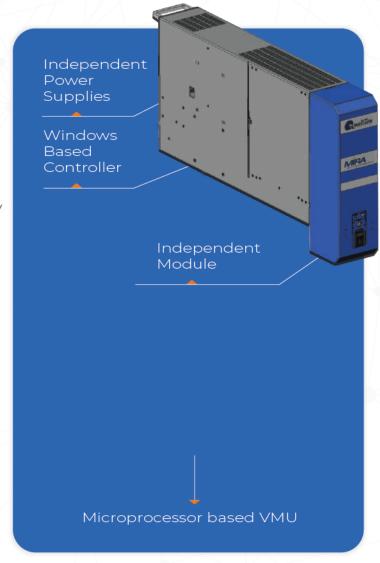




SYSTEM ADVANTAGES:

- One EM module (60 sources) per Micro MIRA.
- Independent Windows-based controller and power supplies per Micro MIRA.
- Individual Voltage Measurement Units (VMUs) provide independent monitoring of stress currents and extrusion monitors, resulting in highly accurate and fast measurements.
- One embedded microprocessor per VMU.
- Field-proven, with installations at major semiconductor companies.
- Occupies less floor space than any other available system.
- Take a system offline without disrupting any other systems.
- Expandable system—add more capacity as needed.



Consult QualiTau for detailed specifications.

TESTING THE FUTURE

